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INFORMATION DISCLOSURE

Substitute for form 14498/PTO

Sheet

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of

STATEMENT BY APPLICANT

	Complete if Known
Application Number	10/630,970
Filing Date	07/31/2003
First Named Inventor	DAVID L O'MEARA
Art Unit	2812
Examiner Name	
Attorney Docket Number	071469-0303786

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.'	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
PO	Α	LIU, H. I. ET AL., "Self-limiting oxidation of Si nanowires," J. Vac. Sci. Technol. B, American Vacuum Society, Vol. 11 (No. 6), p. 2532-2537, (Nov/Dec 1993).	
PD	В	LIU, H. I. ET AL., "Self-limiting oxidation for fabricating sub-5 nm silicon nanowires," Appl. Phys. Letter, American Institute of Physics, Vol. 64 (No. 11), p. 1383-1385, (March 14, 1994).	
PD	С	FUKUDA, HIROSHI ET AL., 'Fabrication of silicon nanopillars containing polycrystalline silicon/insulator multilayer structures,' Appl. Phys. Lett., American Institute of Physics, Vol. 70 (No. 3), p. 333-335, (January 20, 1997).	
PP	D	ROY, P. K. ET AL., "Gate Dielectrics," Bell Labs, p. 276-289.	

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Examiner PHUC T. DANG Date Consider	3/29/05

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Complete if Known Substitute for form 1449A/PTO Application Number 10/630,970 Filing Date INFORMATION DISCLOSURE 07/31/2003 First Named Inventor DAVID L O'MEARA STATEMENT BY APPLICANT Art Unit 2812 Examiner Name (Use as many sheets as necessary) Attorney Docket Number 071469-0303786 Sheet

				U. S. PATENT	DOCUMENTS	
Examiner Initials*	Cite No.1	Document Number  Number-Kind Code <sup>2 (If And</sup>		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
PP	1	US- 6,197,641	ВІ	03-06-2001	HERGENROTHER et al.	
1	2	US- 6,090,723		07-18-2000	THAKUR et al.	
	3	US- 5,817,581		10-06-1998	BAYER et al.	
	4	<sup>UŞ.</sup> 5,334,281		08-02-1994	DOERRE et al.	
V	5	<sup>US-</sup> 5,264,396		11-23-1993	THAKUR et al.	
PP	6	US- 2001/0031562 US-	Al	10-18-2001	RAAIJMAKERS et al.	
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document  Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>3</sup> (#known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Te
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